IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kunihiko SAKURAI et al. :

Serial No. NEW : Attn: APPLICATION BRANCH

Filed January 5, 2004 : Attorney Docket No. 2003-1770

POLISHING APPARATUS (Rule 1.53(b) Divisional of Serial No. 10/026,763, Filed December 27, 2001)

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to the provisions of 37 CFR 1.56, 1.97 and 1.98, Applicants request consideration of [X] the references listed on attached form PTO-1449 and/or [] the additional information identified below in paragraph 3. A legible copy of each reference listed on the form PTO-1449 and each U.S. patent application listed below is enclosed, except a copy is not provided for each reference previously cited by or submitted to the Patent Office in prior parent application Serial No. 10/026,763.

1a. [X] This Information Disclosure Statement is submitted:

within three months of the filing date (or of entry into the National Stage) of the above-entitled application, or

before the mailing of a first Office Action on the merits or the mailing of a first Office Action after the filing of an RCE,

and thus no certification and/or fee is required.

1b.	П	This	Information	Disclosure	Statement	is submitted
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after the events of above paragraph 1a and prior to the mailing date of a final Office Action or a Notice of Allowance or an action which otherwise closes prosecution in the application, and thus:

- (1) [] the certification of paragraph 2 below is provided, or
- (2) [] the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.
- 1c. [] This Information Disclosure Statement is submitted:

after the mailing date of a final Office Action or Notice of Allowance or action which otherwise closes prosecution in the application, and prior to payment of the issue fee, and thus:

the certification of paragraph 2 below is provided, and

the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.

2. It is hereby certified

- a. [] that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Statement, or
- b. [] that no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in §1.56(c) more than three months prior to the filing of the Statement.
- 3. [] Consideration of the following list of additional information (including any copending or abandoned U.S. application, prior uses and/or sales, etc.) is requested.

- 4. For each non-English language reference listed on the attached form PTO-1449, reference is made to:
 - a. [] a full or partial English language translation submitted herewith,
 - b. [] a foreign patent office search report (in the English language) submitted herewith,
 - c. [] the concise explanation contained in the specification of the present application at page,
 - d. [] the concise explanation set forth in the attached English language abstract,
 - e. [] the concise explanation set forth below or on a separate sheet attached to the reference:
- 5. [] A foreign patent office search report citing one or more of the references is enclosed.

Respectfully submitted,

Kunihiko SAKURAI et al.

Nils E. Pedersen

Registration No. 33,145

Attorney for Applicants

NEP/krg Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 January 5, 2004

Sheet 1 of 4										
FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S)				ATTY DOC 2003-17			SERIAL NEW	NO.		
				APPLICANT Kunihiko SAKURAI et al.						
	(Use seve	reral sheets if necessary) ed to PTO: January 5, 20	.,	FILING DA				GROUP		
U.S				.S. PATENT D	OCUMENTS		-	<u> </u>		
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE		NAME	С	LASS	SUBCLASS	FILING D	
	AA	6,062,954	5/2000		Izumi					
	АВ	6,156,124	12/2000		Tobin					
	AC	5,897,426	4/1999	S	Somekh					
	AD	6,036,582	3/2000	Aiza	awa et al.					
	AE	6,180,020	1/2001	Mori	yama et al.					
	AF	5,655,954	8/1997	Oi	shi et al.					
	AG	5,893,795	4/1999	Per	rlov et al.				·- ·- ·	
	АН	5,830,045	11/1998	Tog	awa et al.					
	Ai 5,738,574 4/1998				lles et al.	<u> </u>				
		T	FORE	EIGN PATENT	DOCUMENTS		· · · · · · · · · · · · · · · · · · ·			
		DOCUMENT NUMBER	DATE	C	OUNTRY	CI	ASS	SUBCLASS	TRANSLA YES	ATION NO
	AJ	9-232257	9/1997	<u> </u>	JP					
	AK	97/10613	3/1997		wo	<u> </u>				
	AL	5-285807	11/1993	<u> </u>	JP	ļ				
	АМ	197634	4/1908	G	ermany					
	AN	96/36459	11/1996		wo					
		OTHER	DOCUMENT(S) (I	including Autho	or, Title, Date, Pertine	ent Pages	s, Etc.)			
	AO								;	
	АР	Kaitoh Tei et al., "Pla Working Characteris	Kaitoh Tei et al., "Planarization of Device Wafer with Fixed Abrasive Particles (Second Report)" Planarization Working Characteristics with Fine Silica Grindstone, from the Japan Society for Precision Engineering.							
	AQ	U.S. Patent Application No. 09/663,417, filed September 15, 2000, entitled "Polishing Apparatus", by Kunihiko SAKURAI et al., located in Group Art Unit 3723.								
EXAMINER					DATE CONSIDER	RED				

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FORM PTO 1449 (m	·			ATTY DOCKET NO. 2003-1770		SERIAL NEW				
PAT	TENT AN	RTMENT OF COMMERC ND TRADEMARK OFFICI INCES CITED BY APPLICAN	E	APPLICANT Kunihiko SAKURAI et al.						
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		-		S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT DATE NUMBER			NAME	C	LASS	SUBCLASS	FILING DA		
	AA	5,679,059	10/1997	Nishi et al.	<u> </u>					
	АВ	4,141,180	2/1979	Gill, Jr. et al.					,	
	AC	5,827,110	10/1998	Yajima et al.						
	AD	5,232,875	8/1993	Tuttle et al.						
	AE	5,649,854	7/1997	Gill, Jr.						
	AF	5,562,524	10/1996	Gill, Jr.						
	AG	5,329,732	7/1994	Karlsrud et al.						
	АН	5,554,064	9/1996	Brievogel et al.	Ī					
	AI	5,885,138	3/1999	Okumura et al.						
			FORE	EIGN PATENT DOCUMENTS	<u>.</u>					
		DOCUMENT NUMBER	DATE	COUNTRY	CI	LASS	SUBCLASS	TRANSLA YES	ATION NO	
	AJ	82/03038	9/1982	wo						
	AK	874 309 A1	10/1998	Europe						
	AL	9-232257	9/1997	JP						
	АМ	7-135192	5/1995	JР						
	AN	8-64562	3/1996	JP						
	 ,	OTHER	DOCUMENT(S) (I	Including Author, Title, Date, Pertin	nent Pages	s, Etc.)				
	AO	U.S. Patent Applicati KATSUOKA et al., lo	ion No. 09/341 ocated in Group	1,882, filed September 8, 19 p Art Unit 3723.	999, en	titled "Pe	olishing Apparat	us", by Seiji		
	AP ·	U.S. Patent Applicat SAKURAI et al., loca	U.S. Patent Application No. 09/518,958, filed March 3, 2000, entitled "Polishing Apparatus", by Kunihiko SAKURAI et al., located in Group Art Unit 3723, a C-I-P of application Serial No. 09/476,905, filed January 3, 200							
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FORM PTO 1449 (<i>modified</i>) U.S. DEPARTMENT OF COMMERCE				ATTY DOCKET NO. 2003-1770		SERIAL NEW	NO.			
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			S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT DATE NUMBER		NAME	С	LASS	SUBCLASS	FILING DA	ATE IF RIATE	
	AA	5,616,063	4/1997	Okumura et al.						
	AB	3,906,678	9/1975	Roth						
	AC	3,913,271	10/1975	Boettcher						
	AD	5,718,618	2/1998	Guckel et al.						
	AE	5,989,107	11/1999	Shimizu et al.						
	AF	5,618,227	4/1997	Tsutsumi et al.						
10.00	AG	3,659,386	5/1972	Goetz et al.						
	АН	4,680,893	7/1987	Cronkhite et al.						
	AI	5,551,986	9/1996	Jain						
			FORE	EIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	С	LASS	SUBCLASS	TRANSLA YES	ATION NO	
	AJ	5-285807	11/1993	JP						
	AK	807 492 A2	11/1997	Europe						
	AL	10-256201	9/1998	JP		·				
	AM	5-74749	3/1993	JP						
	AN	2-208931	8/1990	JP						
		OTHER	DOCUMENT(S)	Including Author, Title, Date, Pertin	ent Page	s, Etc.)				
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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE				ATTY DOCKET NO. 2003-1770		SERIAL NEW	NO.				
PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S)				APPLICANT Kunihiko SAKURAI et al	APPLICANT Kunihiko SAKURAI et al.						
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*EXAMINER INITIAL			DATE	NAME			SUBCLASS	SUBCLASS FILING DATE IF APPROPRIATE			
	AA	5,951,373	9/1999	Shendon et al.							
	AB	5,839,947	11/1998	Kimura et al.							
	AC	6,050,884	4/2000	Togawa et al.							
	AD	6,293,855	9/2001	Yoshida et al.							
	AE	5,498,199	3/1996	Karlsrod et al.							
	AF										
	,		FORE	EIGN PATENT DOCUMENTS							
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	AG	4-69147	3/1992	JP							
	. AH	0 517 594	12/1992	Europe							
	AI	0 684 634	11/1995	Europe							
	AJ	2-267950	11/1990	JP							
	ÁK	64-42823	2/1989	JP							
	AL	0761387A1	3/1997	EP							
	АМ	0807492A2	11/1997	EP							
	AN	0928662A2	7/1999	EP							
	АО	0793261A2	9/1997	EP							
		OTHER	DOCUMENT(S) (I	ncluding Author, Title, Date, Pertin	ent Pages	, Etc.)					
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of form with next communication to applicant.